

**Personal info;** Ulf Södervall is responsible for the training and education for new users of the Nanofabrication facility as well as coordinating a PhD course in advanced micro and nanofabrication processing. Process specialist with main focus on CMP (Chemical Mechanical Planarisation) and general wet processing applications; Electrodepositing, wafer cleaning, etching etc. Has a long experience from materials and surface characterisation mainly from SIMS. Coordinates the Myfab National Access program, started up in 2012. Has coordinated the MC2ACCESS (FP6) program during 2006-2010, a program on Access to Research Infrastructure to the MC2 Nanofabrication facility.

The Nanofabrication Laboratory at MC2, Chalmers, Gothenburg, Sweden, is a world-class university cleanroom for research into and fabrication of micro and nanotechnology. The research at MC2 covers a wide range of disciplines in microtechnology and nanoscience. Large efforts, experimental as well as theoretical, are directed at materials, devices and subsystems for future micro/nanoelectronics in the fields of microwave electronics, quantum devices, photonics, micro- and bio- and nanosystems, superconducting devices and circuits and molecular electronics just to mention a few. It is managed by The Department of Microtechnology and Nanoscience (MC2) at Chalmers, but is an open facility for the entire university as well as external academic and commercial interests. Cleanroom operation in its current form was started in 2001. The Laboratory is a state-of-the-art facility with 1240 m<sup>2</sup> of cleanroom classified area with process and measurement tools providing a broad platform for the development and testing of new ideas in micro and nano technology. The Laboratory is also a member of Myfab, the Swedish Research Infrastructure for Micro and Nanoscience and technology. With a unique research competence we offer education at undergraduate level, postgraduate level and within three international master's programmes